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**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**  
(211.001-D2-US)

In re Application of: **FAZAN ET AL.**

Serial No: **10/724,377**

Filing Date: **NOVEMBER 28, 2003**

Title: **SEMICONDUCTOR DEVICE**

) Group Art Unit:

) Examiner:

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)

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I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage in an envelope addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on July 29, 2004  
Date

Michiko Sita  
(person signing this certificate)

Michiko Sita  
Signature

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**THIRD PRELIMINARY AMENDMENT**

Dear Sir:

Prior to the examination of the above-referenced application, kindly amend the application as follows: